



35.C15462

PATENT APPLICATION

2812
#6 / 108
12-3-01
R. Stokes

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KIYOTAKA WASA ET AL.

Application No.: 09/880,757

Filed: June 15, 2001

For: STRUCTURE OF
PIEZOELECTRIC ELEMENT
AND LIQUID DISCHARGE
RECORDING HEAD, AND
METHOD OF MANUFACTURE
THEREOF

Examiner: Not Yet Assigned

Group Art Unit: 2812

October 31, 2001

TECHNOLOGY CENTER 2000

NOV - 5 2001

RECEIVED

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

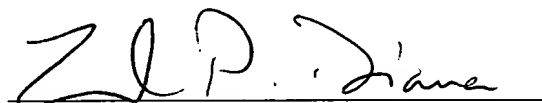
Among the listed documents, the Japanese article, "Sputtering Technologies", is discussed in the specification at page 4, and the Examiner is directed thereto for the concise explanation of relevance of this non-English document. The other listed documents were cited in an August 31, 2001 European search report, a copy of which is also enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


Attorney for Applicants

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